



Docket No.: 5916/FET/FET/DV

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
: Young Joseph PAIK :
: Serial No. 09/998,384 : Group Art Unit: 2812
: Filed: November 30, 2001 : Examiner:
:

For: FEEDFORWARD AND FEEDBACK CONTROL FOR CONDITIONING OF
CHEMICAL MECHANICAL POLISHING PAD

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REQUEST FOR CHANGE OF CORRESPONDENCE ADDRESS

Honorable Commissioner for Patents
Washington, D.C. 20231

Sir:

The undersigned Principal Attorney of record hereby requests that **all correspondence** for the above-identified patent application be directed to the following address:

Patent Counsel, MS/2061
Legal Affairs Department
Applied Materials, Inc.
P.O. Box 450A
Santa Clara, CA 95052

Respectfully submitted,
HALE AND DORR LLP

Scott M. Alter
Registration No. 32,879

1455 Pennsylvania Avenue, NW
Washington, DC 20004
Tel. 202-942-8428
Fax 202-942-8484
Date: 4/16/02